

CUSTOMER NO. 27123  
Docket No. 6009-4721

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): LEIMALA  
Serial No.: Not Yet Assigned  
Filed: Herewith  
For: METHOD FOR THE PURIFICATION OF COPPER CHLORIDE SOLUTION  
Group Art Unit: Not Yet Assigned  
Examiner: Not Yet Assigned

**INFORMATION DISCLOSURE STATEMENT**

Mail Stop PCT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to Rule 56, applicant hereby calls the attention of the Patent Office to the references listed on the attached Form PTO 1449. Copy(ies) of these references ☒ are enclosed.

- ☒ This document is being filed within three (3) months of the filing date of the application
- ☐ Please charge the \$180 fee to Deposit Account No. 13-4500, Order No. \_\_\_\_\_.
- ☐ This document is being concurrently filed with the above-identified application
- ☐ This document is being concurrently filed with an Request for Continued Examination (RCE)
- ☐ This document is being filed prior to a first Office Action
- ☒ This document is accompanied by a Search Report/Communication cited in a corresponding PCT or foreign counterpart application.
- ☒ The Commissioner is hereby authorized to charge any additional fees which may be required for this Information Disclosure Statement, or credit any overpayment to Deposit Account No. 13-4500, Order No. 6009-4721. A DUPLICATE COPY OF THIS SHEET IS ATTACHED.

Respectfully submitted,



Israel Blum  
Registration No. 26,710  
Attorney for Applicant

Dated: October 14, 2004

Correspondence Address:  
MORGAN & FINNEGAN, L.L.P.  
3 World Financial Center  
New York, NY 10281 2101  
(212) 415-8700 Telephone  
(212) 415-8701 Facsimile

<b>FORM PTO-1449</b>			Attorney Docket: 6009-4721		Serial No. <b>10/511290</b> Not Yet Assigned		
<b>INFORMATION DISCLOSURE CITATION</b>			Applicant: LEIMALA				
			Filing Date: Herewith		Group Art Unit: Not Yet Assigned		
<b>U.S. PATENT DOCUMENTS</b>							
<b>Examiner Initial</b>		<b>Patent Number</b>	<b>Publication Date</b>	<b>Name</b>	<b>Class</b>	<b>Sub- Class</b>	<b>Filing Date</b>
		3,951,649	April 20, 1976	KIESWETTER, Jr. et al	75	117	August 19, 1974
		4,297,183	October 27, 1981	GEORGEAUX	204	117	August 12, 1980
		3,873,668	March 25, 1975	RUSSELL	423	24	March 27, 1973
		6,007,600	December 28, 1999	HYVARINEN et al	75	740	August 25, 1998
<b>FOREIGN PATENT DOCUMENTS</b>							
<b>Examiner Initial</b>		<b>Patent Number</b>	<b>Publication Date</b>	<b>Country</b>	<b>Class</b>	<b>Sub- Class</b>	<b>Translation</b>
<b>OTHER DOCUMENTS (Including Author, Title, Date, etc.)</b>							
		Kekesi, Tamas et al "Preparation of Ultra-High-Purity Copper by Anion Exchange"; <i>Metallurgical and Materials Transactions B</i> , Vol 28B, No. 987, December 1997					
		Koivula, Risto et al; "Purification of Metal Plating Rinse Waters with Chelating Ion Exchangers" <i>Hydrometallurgy</i> , Vol 56, Pg 107, 2000					
Examiner				Date Considered			
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP §609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.							